

DATA ANALYSIS AND CONTROL OF AN MeV ULTRAFAST ELECTRON DIFFRACTION SYSTEM AND A PHOTOCATHODE LASER AND GUN SYSTEM USING MACHINE LEARNING*

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Abstract

An MeV ultrafast electron diffraction (MUED) instrument system is a unique characterization technique used to study ultrafast processes in a variety of materials by a pump-probe method. This technology can be advanced further into a turnkey instrument by using data science and artificial intelligence (AI) mechanisms in conjunction with high-performance computing. This can facilitate automated operation, data acquisition, and real-time or near-real-time data processing with minimal intervention by a beamline scientist. The AI-based system controls can also provide real-time electron beam optimization or provide virtual diagnostics of the beamline operational parameters. Deep learning can be applied to the MUED diffraction patterns to recover valuable information on subtle lattice variations that can lead to a greater understanding of a wide range of material systems. A data-science-enabled MUED facility will also facilitate the application of this technique to a wider user base, and provide an automated or semi-automated state-of-the-art instrument, with a beamline scientist assisting in the overall data collection process. Updates on research and development efforts for the MUED instrument in the Accelerator Test Facility of Brookhaven National Laboratory are presented.

INTRODUCTION

An MeV ultrafast electron diffraction (MUED) system is a pump-probe characterization technique for studying ultrafast processes in materials. The MUED beamline at the Brookhaven National Laboratory's (BNL's) Accelerator Test Facility (ATF) operates at 3 MeV. The use of relativistic electron beams leads to decreased space-charge effects compared to typical ultrafast electron diffraction experiments employing energies in the keV range [1-3]. MUED has a higher scattering cross section with material samples as compared to other probes such as X-ray free electron lasers (FELs), and as such allows access to higher-order reflections in the diffraction patterns due to the short electron wavelengths.

However, this is a relatively young technology, and several factors contribute to making it challenging to utilize, such as beam energy instabilities that can lower the effective spatial and temporal resolution. Because there are many types of samples that are scientifically important but

the groups that wish to study them are not necessarily experts in MUED beamlines, it is attractive that the data collection process become more automated. In recent years, machine learning (ML) approaches to materials and characterization techniques have provided a new path towards unlocking new physics by improving existing probes and increasing the user's ability to interpret data. Ideally, anomalous contribution detection and removal should not require *a priori* knowledge of what those contributions would be or how they would present themselves in the data. Particularly, with proper preprocessing, ML methods can be employed to control characterization probes in near-real time, acting as virtual diagnostics, or ML can be deployed to extract features and effectively denoise data. With respect to denoising, convolutional neural network (CNN) architectures, such as auto encoder models, are an attractive and more powerful alternative to conventional denoising techniques. The autoencoder models provide a method of unsupervised learning of latent space representation of data that can help reduce data noise. It should be noted that noise and anomalies aren't necessarily the same thing, as systematic stochastic noise issues may be present. In principle, AI/ML can facilitate distinguishing both.

By supplying a paired training dataset of "noisy" and "clean" data, these ML models can effectively denoise measurements [4, 5]. This method relies on the existence of an ideal dataset with no noise, which can be obtained by simulation or by averaging existing noisy datasets. However, in some cases these are not accessible or practical to use. Generative adversarial networks (GANs) are a more suitable option when no "clean" data are available and have been proven to perform well for blind image denoising [6]. They can be trained to estimate and generate the noise distribution, thus producing paired training datasets that can be fed to an autoencoder model. These approaches can lead to increased resolution if employed to denoise, for example, diffraction patterns. In addition, deep CNN architectures can be used for data analysis. Laanait *et al.* measured diffraction patterns of different oxide perovskites using scanning transmission electron microscopy and, by applying a custom ML algorithm, were able to invert the materials structure and recover 3-dimensional atomic distortions [7]. ML is just now being applied to the MUED technique, where it can certainly enable advances that can further understanding of ultrafast material processes.

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EXPERIMENTAL

The MUED instrument is located at the Accelerator Test Facility at Brookhaven National Laboratory. A schematic of the experimental setup is presented in Fig. 1. The details of data collection are very briefly described here. The femtosecond electron beam is generated using a frequency-tripled Ti:Sapphire laser that illuminates a copper photocathode, generating a high brightness beam. The electrons are bunched in a 1.6-cell rf cavity and accelerated to 3 MeV. Current parameters of the electron beam source optimized for stability are presented in Table 1. The sample chamber is located downstream from the source with a motorized holder for up to nine samples with cryogenic cooling capabilities and a window to allow laser pumping of the material. The detector system is placed 4 m downstream of the photocathode to collect the diffraction patterns. The detector consists of a phosphor screen followed by a copper mirror (with a hole for non-diffracted electrons to pass through) and a CCD Andor camera of 512 pixels \times 512 pixels with a large aperture lens.

Suitable material systems for MUED require careful preparation with typical lateral sizes of 100-300 μm and roughly - 100 nm thickness to assure electron transparency. Laser fluency is adjusted to avoid radiation-induced damage to the sample.

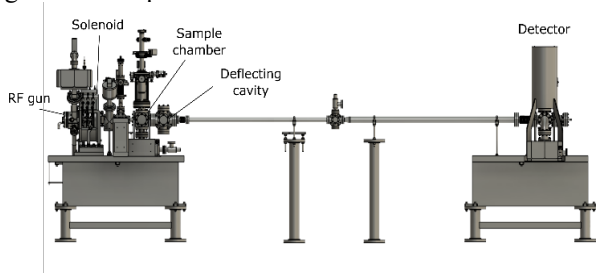


Figure 1: MUED beamline schematic.

Table 1: MUED Source Parameters for Typical Operation

Beam Energy	3 MeV
Electrons per pulse	1.25×10^6
Temporal resolution	180 fs
Beam diameter	100-300 μm
Repetition rate	5-48 Hz
Electron fluence	$88\text{-}880 \text{ s}^{-1}\mu\text{m}^{-2}$

A schematic of the data pre-processing for ML application for noise detection and removal is presented in Fig. 2. A given image (dataset) is divided into an array of tiles in Fig. 2(a). Noting that for N samples with white noise all frequencies contribute equally to a function, these tiles are examined for those having an inverse participation ratio (IPR) value of $1/N$. The IPR is a measure of the contribution of each frequency (in this case spatial). These tiles are ignored. The resulting image is shown in Fig. 2c.

UPDATES

The team has traveled to the ATF facility for beamline training and to gain more intimate understanding of the data collection process and facility operations. A procedure for beamline operations has been drafted, with the expectation that the “knobs” identified for manual alignment and data evaluation can be used in the ML-based approach. A method for remote communication with the beamline has been identified and tested. A camera API environment has been initialized, and computer code to call Andor library functions and confirm communication between stand-alone scripts and the camera has also been developed for image export to the Argonne Leadership Computing Facility (ALCF).

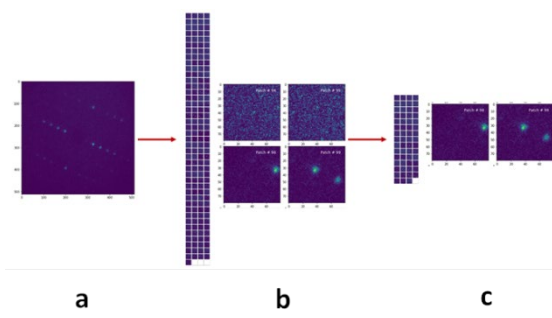


Figure 2: ML schematic for data denoising.

CONCLUSIONS AND FUTURE PLANS

MeV ultrafast electron diffraction (MUED) is a pump-probe system to measure dynamic material structure evolution in the time range from femtoseconds to nanoseconds. A convolutional autoencoder model was developed to reconstruct large sets of diffraction patterns. The model trained on all data (unsupervised). An anomaly was found to produce a large reconstruction error or different feature vector values. Anomaly detection is ongoing, and multiple approaches are being considered. The large datasets expected from the ATF are well suited for data analysis on a high-performance computing system, such as at the Argonne Leadership Computing Facility, located at Argonne National Laboratory. There is an existing account at THETA and THETAGPU for this work.

In order to evaluate data quality by use of a beamline sample, and extension to the beamline with a spectrometer for energy calibration has been initiated and is depicted in Fig. 3.

This work has been further documented in several talks [8-15]. Also, a manuscript is in preparation on unsupervised anomaly detection for MeV ultrafast electron diffraction (M. Fazio *et al.*; in preparation.). Applications of ML combined with MeV ultrafast electron diffraction at facilities such as the ATF are expected to encompass not only materials science; interest has been expressed in global security challenges such as pandemics and alternative solar-based energy source development.

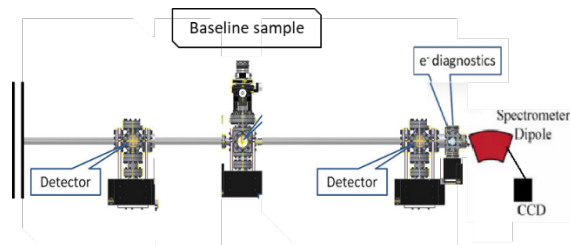


Figure 3: Downstream portion of the MUED beamline with spectrometer extension.

Finally, some of our team members are part of the Center for Bright Beam (CBB) [16] and are working to improve a similar photocathode RF electron injector system to that of the MUED located at the main ATF linac [17]. This knowledge can also be transferred to the MUED user facility after it has been fully implemented on the ATF. Based on previous work funded by the DOE on laser control for the laser for a laser wakefield accelerator (LWFA), have developed a machine learning-based (ML-based) model of a laser system for an RF electron in which correlates the inputs and outputs using 3 hidden layers (N) and 5, 10, and 15 neurons [18]. Based on this approach, which utilizes SLM (Spatial Light Modulator) technology, we are seeking to optimize the set of inputs, which include the drive laser shape and the photoinjector and electron beam setpoint parameters to produce an optimized electron beam output based mostly on shaping the laser beam's profile. Again, the application is also in a similar approach for the MUED to control the inputs and outputs of the laser system and represents a significant contribution to the field of laser technology and machine learning and highlights a promising avenue for future research and potential practical applications in diverse fields through an inter-institution collaborative effort that merges experimental and architectural approaches to laser (and accelerator) control).

ACKNOWLEDGEMENTS

Work was supported by the U.S. Department of Energy, Office of Science, Office of Basic Energy Sciences, Materials Science and Engineering Division, Program of Electron and Scanning Probe Microscopies, award DE-SC0021365. Funding was available through the Department of Energy's Established Program to Stimulate Competitive Research (EPSCoR) State-National Laboratory Partnerships program in the Office of Basic Energy Sciences. This research used resources of the Argonne Leadership Computing Facility, which is a DOE Office of Science User Facility supported under Contract DE-AC02-06CH11357. This research used resources of Brookhaven National Laboratory's Accelerator Test Facility, an Office of Science User Facility. MMR partly supported by the King Felipe VI endowed chair of the University of New Mexico. This work was also supported by the U.S. National Science Foundation under Award PHY-1549132, the Center for Bright Beams.

REFERENCES

- [1] X. J. Wang *et al.*, "Femto-seconds Electron Beam Diffraction Using Photocathode RF Gun", in *Proc. PAC'03*, Portland, OR, USA, May 2003, paper WOAC003, pp. 420-422.
- [2] P. Zhu *et al.*, "Femtosecond time-resolved mev electron diffraction", *New J. Phys.*, vol. 17, no. 6, p. 063004, 2015. doi:10.1088/1367-2630/17/6/063004
- [3] M. G. Fedurin *et al.*, "Commissioning and Operation of an Ultrafast Electron Diffraction Facility as Part of the ATF-II Upgrade at Brookhaven National Laboratory", in *Proc. IPAC'17*, Copenhagen, Denmark, May 2017, pp. 554-556. doi:10.18429/JACoW-IPAC2017-MOPIK026
- [4] T. Konstantinova *et al.*, "Noise Reduction in X-Ray Photon Correlation Spectroscopy with Convolutional Neural Networks Encoder-Decoder Models", 2021. arXiv:2102.03877
- [5] X-J Mao *et al.*, "Image Restoration Using Very Deep Convolutional Encoder-Decoder Networks with Symmetric Skip Connections", 2016. arXiv:1603.09056
- [6] J. Chen *et al.*, "Image Blind Denoising with Generative Adversarial Network Based Noise Modeling", in *Proc. IEEE Conference on Computer Vision and Pattern Recognition*, Salt Lake City, UT, USA, Jun 2018, pp. 3155-3164. doi:10.1109/CVPR.2018.00333
- [7] N. Laanait *et al.*, "Reconstruction of 3-D Atomic Distortions from Electron Microscopy with Deep Learning", 2019. arXiv:1902.06876
- [8] M. Fazio *et al.*, "Autonomous Anomaly Detection in MeV Ultrafast Electron Diffraction", presented at Artificial Intelligence for Robust Engineering and Science (AIRES 3): Machine Learning for Robust Digital Twins, Oak Ridge, TN, USA, Apr 26-28, 2022, hybrid workshop.
- [9] M. Fazio *et al.*, "Autonomous anomaly detection in MeV ultrafast electron diffraction", presented at American Physical Society March Meeting 2022, Chicago, IL, USA, Mar 14-18, 2022.
- [10] S. Biedron *et al.*, "Updates in Efforts to Data Science Enabled MeV Ultrafast Electron Diffraction System", in *Proc. IPAC'22*, Bangkok, Thailand, Jun. 2022, pp. 397-399. doi:10.18429/JACoW-IPAC2022-MOPOPT057.
- [11] T. Bolin *et al.*, "Data Analysis and Control of a MeV Ultrafast Electron Diffraction System using Machine Learning", presented at 3rd ICFA Beam Dynamics Mini-Workshop on Machine Learning Applications for Particle Accelerators Hosted by Brookhaven National Laboratory, Chicago, IL, USA, Nov. 1-4, 2022.
- [12] T. Bolin *et al.*, "UE117 Advanced Control of the ATF MUED Electron Beam Using Automation, Artificial Intelligence, and High-Performance Computing UE110-Baseline materials for characterizing the MUED configuration, their role verifying daily alignment and in operation and implementation of a non-destructive real-time machine learning diagnostic for ensuring beam stability", presented at the 25th Accelerator Test Facility Users' Meeting, Hosted by Brookhaven National Laboratory, Upton, New York, USA, Feb. 28-Mar. 2, 2023.
- [13] T. Bolin *et al.*, "Use of Carbonyl as an Infrared Reporter for Probing the Nature of Charges in Donor-Acceptor Type Conjugated Molecules", presented at 2023 Annual Directed

Energy Science and Technology Symposium, San Antonio, Texas, USA April 3-6, 2023.

- [14] S. G. Biedron, “Accelerator Development for Global Security”, presented at LINAC’22, Liverpool, England, Apr-Sep 2022.
- [15] S.G. Biedron, “Data Driven Concepts For Laser And Particle Accelerator-Based User Facility Systems: All Systems Work Together,” Invited Session - Let There Be Data: Analyzing Data From Lasers And Light Sources,” Conference on Data Analysis, Santa Fe, New Mexico, March 5-7 2023.
- [16] Cornell, <https://cbb.cornell.edu/>
- [17] A. Aslam *et al.*, “Applications of Machine Learning in Photo-Cathode injectors,” presented at NAPAC’22, Albuquerque, NM, USA, Aug 2022, paper TUPA41, unpublished.
- [18] A. Aslam *et al.*, “Convolutional neural network-based modeling of an ultrafast laser for superior control,” submitted to Nuclear Instruments and Methods in Physics Research A, submitted for publication